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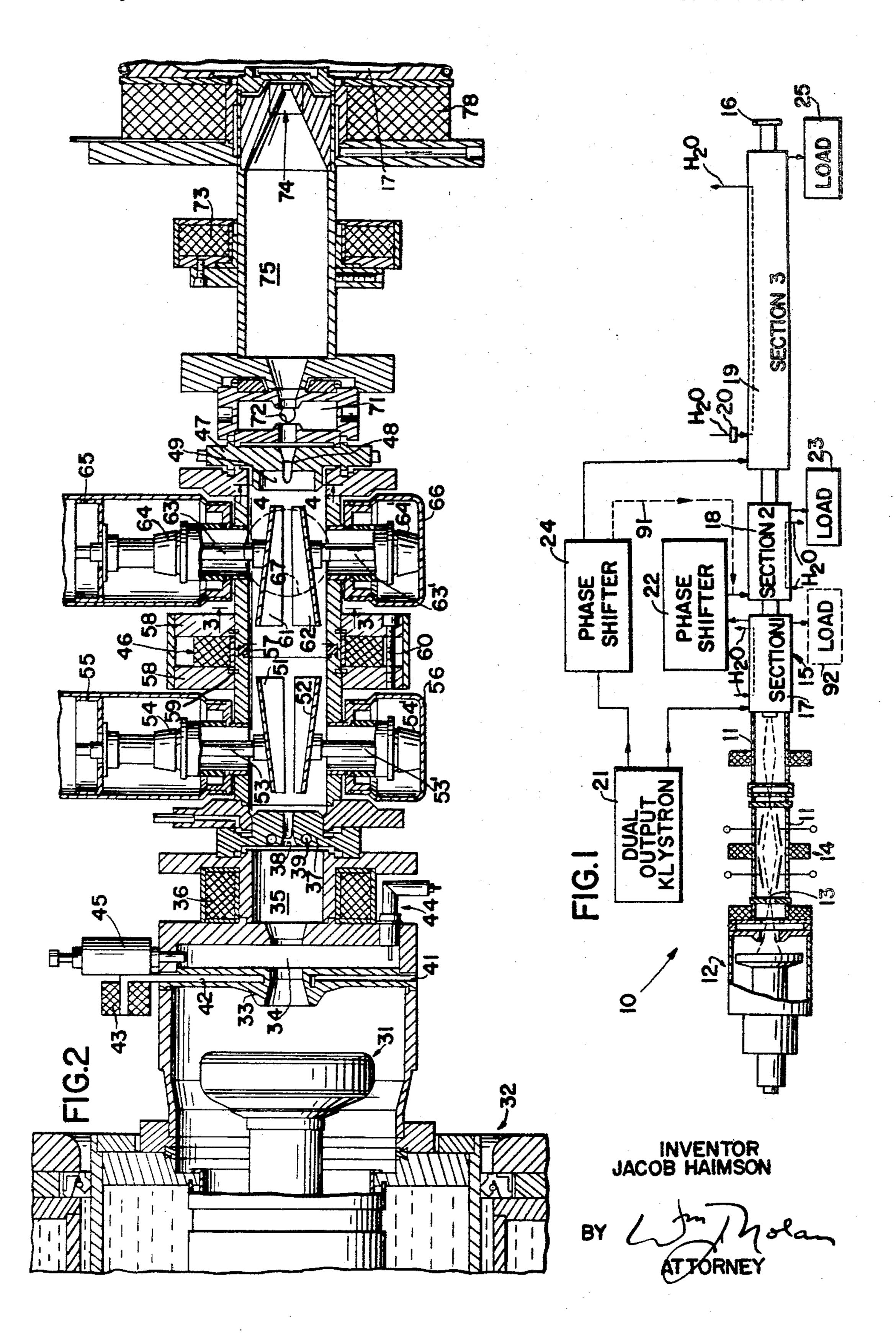
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APPARATUS AND METHOD FOR SELECTIVELY PRODUCING HIGH CURRENT OF HIGH ENERGY BEAMS OF

ACCELERATED CHARGED PARTICLES

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2 Sheets-Sheet 1



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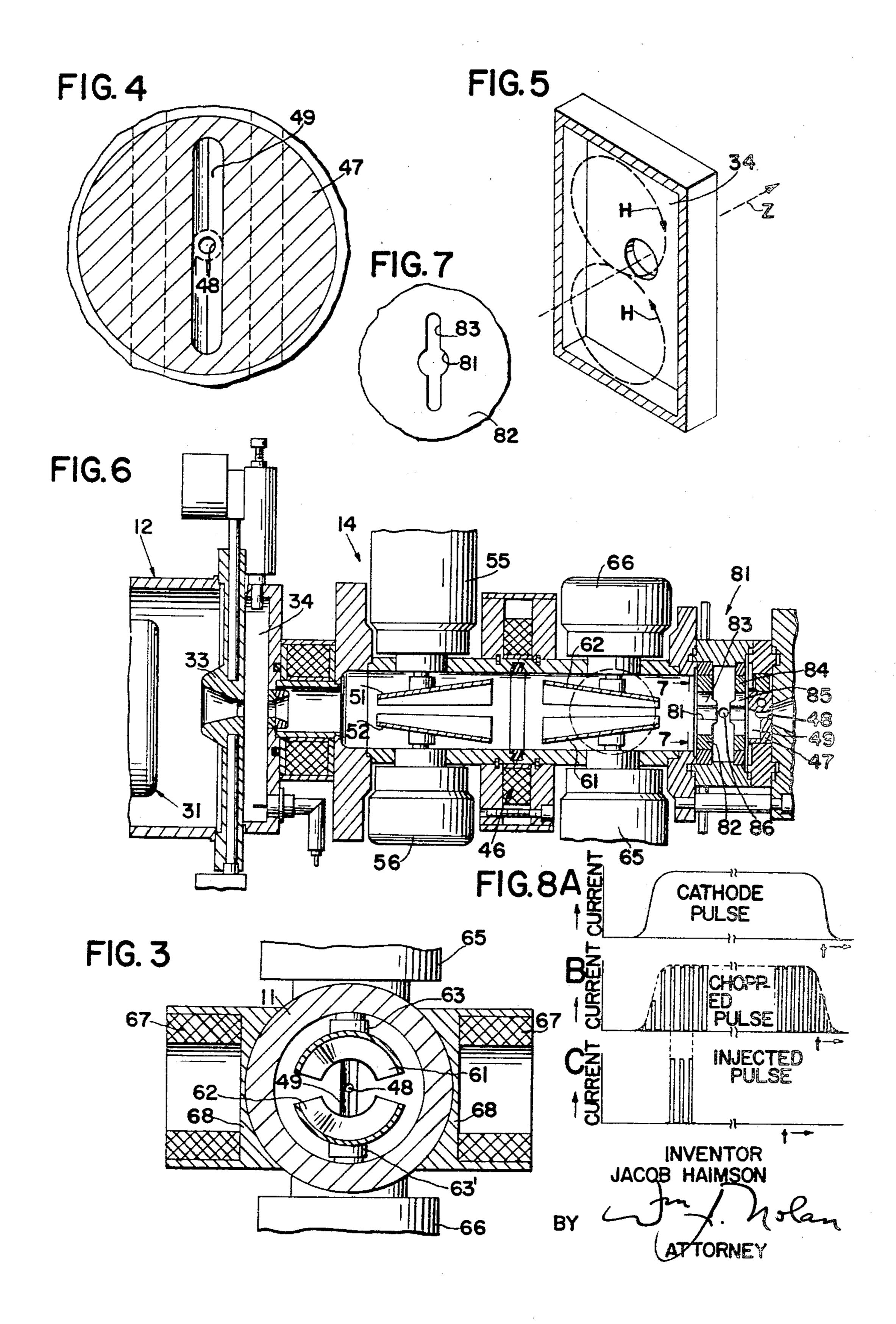
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APPARATUS AND METHOD FOR SELECTIVE-LY PRODUCING HIGH CURRENT OF HIGH ENERGY BEAMS OF ACCELERATED CHARGED PARTICLES

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ABSTRACT OF THE DISCLOSURE

In a linear particle accelerator having at least three accelerating sections, a dual output klystron provides input power into the first section and into the second or third sections depending on whether a high current or high energy output is desired. In the high current mode, the input power is coupled into the second section through a phase shifting switching circuit with the residual energy remaining at the output of the first section being dissipated in an external load. In the high energy mode, the phase shifting switching circuit couples the input power into the third section with the residual energy remaining at the output of the first section being coupled through a second phase shifting switching circuit into the second section instead of the load. A heater is provided in the cooling lines of the third section to control the temperature and electrically decouple the third section during high current operation in rder to effect a zero net energy transfer from the particle beam to the waveguide section as the beam passes therethrough.

The present invention relates in general to particle 35 accelerators and more particularly to multiple section linear particle accelerators.

In the acceleration of particles such as, for example, electrons and positrons to high energy in a linear particle accelerator, the ultimate beam energy and beam current 40 are dependent upon the impedance and length of the accelerating waveguide and the applied RF power. Alternately, the length and impedance characteristics of the waveguide structures are dependent upon the required beam energy and the efficiency of conversion from RF power to particle beam power. Also because the input RF power is limited from each klystron RF power source to, on the order of 20–30 mw., high power beam performance requires multiple klystrons and accelerating waveguide sections. It is often desired to utilize the particle beam over a wide variation of current and energy levels at the end of the several accelerator sections.

The object of the present invention is to provide a multiple section linear accelerator that will produce multiple performance specifications without changing the parameters of the injection and bunching systems of the accelerator.

One aspect of the present invention is the provision of a dual purpose accelerating structure which can be adjusted for multiple performance specifications such as either high current, medium energy output or high energy medium current output. In accordance with this aspect of the present invention a series of at least three accelerating sections are provided with means for directing input power into the first section and other input power either into the second section for high current operation or into the third section for high energy output in which case means are provided for coupling the energy remaining at the end of the first section into the second section. For high current operation of the accelerating structure provision is made for either displacing or decoupling the third section for utilization of the

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particle beam current and energy emanating from the second section. This accelerator construction permits the trapping and bunching electric fields which vary from cavity to cavity in the initial accelerating waveguide, to be utilized and maintained for both high current and high energy operation.

Another feature of the present invention is provision for decoupling one section of a plurality of accelerating waveguide sections from the particle beam transmitted therethrough by changing the operating temperature of the section thereby to change the dimensions and thus the phase of the traveling RF wave with respect to the beam particle bunches in such a manner that there is a zero net energy transfer from the particle beam to the waveguide section upon passage therethrough.

These and other features and advantages of the present invention will be more apparent upon a perusal of the following specification taken in connection with the accompanying drawings wherein:

FIG. 1 is a schematic view partially broken away of a linear accelerator incorporating features of the present invention;

FIG. 2 is an enlarged elevational sectional view of a portion of the structure schematically illustrated in FIG. 1;

FIG. 3 is a sectional view of a portion of the structure shown in FIG. 2 taken along line 3—3 in the direction of the arrows;

FIG. 4 is an enlarged sectional view of a portion of a structure shown in FIG. 2 taken along line 4—4 in the direction of the arrows;

FIG. 5 is an enlarged perspective view partially in section schematically illustrating a main chopping cavity in accordance with the present invention;

FIG. 6 is a sectional view of an alternative structure in accordance with the present invention;

FIG. 7 is a sectional view of a portion of the structure shown in FIG. 6 taken along line 7—7 in the direction of the arrows; and

FIGS. 8A-8C are graphs of current versus time for particles in certain portions of a machine employing the present invention.

The present invention is directed primarily to a pulsing apparatus which can be utilized in a particle accelerator such as, for example, an electron linear accelerator. While the invention will be described hereinafter with particular reference to an electron linear accelerator it can be utilized with other pulse particle utilizing apparatus such as, for example, positron accelerating structures.

Referring now to the drawings, with particular reference to FIG. 1, there is schematically illustrated a particle accelerator 10 which includes an elongate vacuum envelope 11 with a beam generating assembly 12 for generating and directing a particle beam 13 longitudinally of the envelope 11. A beam deflecting and injecting assembly 14 is disposed along the envelope 11 between the beam generating assembly 12 and a particle accelerating wave guide 15 which is provided at its output end with an output window 16 through which a pulse of electrons which have been accelerated to relativistic velocities can be passed for performing sophisticated nuclear experiments or for direction onto a target electrode for generating other radiation such as, for example, X-rays.

The accelerating wave guide 15 includes a plurality of wave beam interaction structure 17, 18 and 19 such as, for example, apertured disc-loaded wave guide for transferring energy from radio frequency electromagnetic waves to charged particles such as, for example, electrons passing therethrough for accelerating the electrons to relativistic velocities. The accelerating wave guide 15 is energized by a high power RF source such as, for example, a dual output klystron tube 21 in which

the microwave energy from one of the output arms is fed into section 17 for transmission therethrough, through a phase shifter 22 and through section 18 for interaction with a pulse of charged particles directed therethrough from the beam generating assembly 12. The accelerating sections 17, 18 and 19 are fluid-cooled such as, for example, by water for absorption of the heat dissipated in the waveguide by the RF power, and residual RF power remaining at the end of section 18 can be coupled to a load 23. RF energy from the other output arm of 10 the klystron 21 is coupled through a phase shifter 24 into the accelerating section 19 in proper phase relation with respect to the partially accelerated pulse of charged particles to continue accelerating the particles until they reach the end of the accelerating section 19 and are passed through the window 16 or into other apparatus for utilization. Residual RF power at the output end of accelerating section 19 can be passed into an external load 25. The fluid-cooling assembly for the third accelerating section 19 is provided with a heater 20 for changing the 20 temperature of the cooling fluid, thereby to decouple the section 19 from the particle beam.

The beam generating assembly 12 and the beam deflecting and injection assembly 14 are constructed for producing pulses of charged particles having a pulse 25 length continuously variable down to a minute fraction of a second.

Referring now to FIG. 2 which illustrates an enlarged view of assemblies 12 and 13, the beam generating assembly 12 includes a cathode and focus electrode assembly 31 which is mounted at the one end of the envelope 11 and whichd uring operation is positioned in an electrical insulating oil bath 32. Spaced along the axis of the particle accelerator 10 from the cathode of focus electrode assembly 31 is an apertured anode 33 which is followed by a beam chopping cavity resonator 34 which will be described in greater detail below with reference to FIG. 5.

A drift space 35 is positioned along the beam path following the cavity resonator 34 and is surrounded by a magnetic lens 36 for focussing the particle beam 13 onto a collector 37 or through a collimating aperture 38 in the collector 37 for passing short pulses of charged particles through the collimating aperture 38 into the beam deflecting and injection assembly 14. The collector 37 and the anode 33 are provided with water-cooling channels 39 and 41 respectively for passing cooling fluid through these respective electrodes to cool the electrodes which are heated due to interception of the charged particles.

A plurality of separate beam steering probes are provided around the aperture in the anode 33 and include a steering rod 42 of magnetic material which projects radially outwardly of the anode 33 with its exterior end surrounded by a coil 43 for changing the magnetic field 55 established at the interior ends of the steering rods 42.

A coupling loop 44 is provided for coupling RF energy into the cavity resonator 34 which can be tuned to the desired operating electromagnetic mode by means of the tuner schematically illustrated at 45.

The beam deflection assembly 14 spaced axially down the envelope 11 from the collector 37 includes a focusing lens 46 such as, for example, a thin magnetic lens coil for focusing the diverging pulsed electron beam 13 onto a subsequently positioned collecting electrode 47 or through an axially aligned collimating aperture 48 in the collector 47. A first pair of deflection plates 51 and 52 is located on opposite sides of the beam path between the collector 37 and the lens 46 for deflecting the pulsed electron beam 13 from a position in which the beam impinges on the collector 47 to a position for passage through the collimating aperture 48. The collector 47 is provided with an energy distributing slot 49 (see FIG. 4), V-shaped in cross-section, extending across the collector on opposite sides of the collimating aperture 48 for collecting the 75

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beam focused thereinto over a large surface area. The pulse of charged particles is swept longitudinally of the slot 49 during operation of the deflecting assembly as described in detail below. The collector 37 is provided with a similar energy distributing slot along which the pulse of charged particles is swept by the fields in the beam chopping cavity resonator 34.

Each of the deflection plates 51 and 52 is semi-cylindrical in form tapering outwardly in the direction of beam travel and is supported on one end of a conducting rod 53, the other end of which is supported in a vacuum seal assembly 54 located in the envelope 11. The conducting rod 53 which supports the deflection plate 51 is connected to a thyratron 55 which is coaxially supported with respect to the vacuum seal 54. The conducting rod 53' which supports the deflection plate 52 is connected to ground via a metallic cup-shaped member 56 which surrounds the vacuum seal 54' and is electrically connected to the body of the metallic envelope 11.

A second pair of deflection plates 61 and 62 is located between the lens 46 and the collector 47 for deflecting the electron beam from the position in which it passes through the collimating aperture 48 to a position for ampringement on the collector 47. These plates 61 and 62 are shaped similarly to plates 51 and 52 but tapered inwardly toward the axis in the direction from the lens 46 to the collector 47. Plate 61 is connected via connecting support rod 63, through a vacuum seal 64 to a coxially mounted thyratron 65 while plate 62 is connected via support rod 63', through vacuum seal 64' and via a metallic cup-shaped member 66 to the envelope 11 and ground. The second pair of deflection plates 61 and 62 is rotated (not shown) about the envelope 11 axis with respect to the pair of plates 51 and 52 to allow for rotation imparted to the beam in passing through the lens 46, and this rotation is accomplished by a rotatable vacuum joint in the envelope at the lens 46. This vacuum joint includes a metal gasket vacuum seal 57 which is held together by a pair of rotatable flanges 58 rotatably secured on the envelope 11 on opposite sides of the magnetic lens 46 by retaining rings 59 and held together by a plurality of bolts 60.

A magnetic bias field is produced in the region between the second pair of plates 61 and 62 by a pair of electric coils 67 provided with end pole pieces 68 located against the exterior of the envelope 11 midway between the deflection plates 61 and 62 as shown in greater detail in FIG. 3. The magnetic bias field produced by the coils 68 counterbalances the electric field between plates 61 and 62 so that for operation of the deflection assembly as described in greater detail below plate 62 can be grounded, thereby avoiding problems of voltage variation on plate 62 and consequent variation in electric field strength between the plates due to interception of charged particles on plate 62.

The electric field between each pair of deflection plates can be separately controlled as will be described in greater detail below for deflecting the electron beam between the position off the axis of the envelope 11 for 60 collection on collector 47 to a position on the axis of the envelope 11 for passage through the collimating aperture 48. In this manner an easily adjusted short pulse of electrons can be passed through the collimator 48 into a prebuncher cavity 71 in which RF fields are established such as, for example, by an RF signal introduced thereinto via an input coupling loop 72. The bunched short pulse of charged particles emanating from the prebunching cavity 71 is focused to a small diameter by means of, for example, a thin magnetic lens coil 73 and directed into the input end of the first accelerator section 17 through a collimating aperture 74. The focusing coil 73 is axially slidable along the length of a drift space 75 between the prebunching cavity 71 and the collimating aperture 74 for producing an optimum focus of the pulse of charged particles into the accelerating structure.

Referring now to FIG. 5, the chopping cavity 34 has oscillating magnetic fields across the beam path through the center of the cavity and this region of the cavity is free from counterbalancing deflecting electric fields. As shown, the cavity resonator 34 is a rectangular cavity 5 operating in the TE₁₀₂ mode. The electric fields associated with the deflecting magnetic fields illustrated in FIG. 5 are threaded through the magnetic fields and rather than existing at the center of the cavity where the beam path lies are distributed such as to provide a peak field between 10 the beam hole and the cavity end walls. Alternatively, the cavity resonator can be circular resonator operating in the TM₁₁₀ mode for producing the same particle deflection effects as the rectangular cavity described above. Here again in the circular TM₁₁₀ cavity resonator the 15 oscillating magnetic fields arranged transverse to the cavity axis in the pattern as shown in FIG. 5 for a rectangular cavity are concentrated on the beam axis of the accelerator with the electric fields concentrated remote therefrom. With the particle beam directed through the 20 cavity resonator centrally thereof, the particle beam is subjected to deflecting magnetic fields without being subjected to compensating or counterbalancing deflecting electric fields.

Chopping cavities operating in higher order modes 25 such as, for example, rectangular TE_{10n} and circular TM_{1mo} , where n and m are integers and $n \ge 2$ can be utilized so long as the relationship of beam path to the magnetic and electric fields is similar as for the primary modes described above.

Operation of the method and apparatus in accordance with the present invention will be described with a typical operating example. A pulsed electron beam is produced in the beam generating assembly 12 having a pulse duration of approximately several microseconds, a rise time 35 on the order of tenths of microseconds, and a peak beam current on the order of approximately 4 amps, such as illustrated schematically in FIG. 8A. The beam steering coils are properly adjusted to focus the beam pulse into the V-shaped groove in the collector 37 and biased to 40one side of the collimating aperture 38 so that during deflection in the chopper cavity and at only one end of the chopper deflection pattern the particle pulse is directed through the collimating aperture 38 for transmission into the deflection assembly 14, i.e., only one burst of par- 45 ticles per RF cycle. When the beam pulse is not biased to one side of the collimating aperture two particle bursts are transmitted per cycle and, for example, when injected into a linear accelerator only one burst will be accepted; the other (displaced 180° in phase) will be automatically 50 rejected by the reversed high electric field in the accelerator. An RF signal such as, for example of S-band frequency is fed into the chopper cavity to sweep the pulsed particle beam across the collector 37 so that only a portion of the particle pulse is passed through the collimat- 55 ing aperture 38 into the deflecting assembly each cycle of the oscillating electromagnetic fields within the chopper cavity 34, as illustrated schematically in FIG. 8B. The duration of the cycle in the chopping cavity is, for this example, about 1/3 nanosecond, and the duration of each 60 individual burst of particles passed from the chopping cavity into the deflection assembly depends upon the ratio of beam diameter to collimator aperture and the magnitude of scan in the chopper cavity. By passing charged particles into the deflecting assembly during only about 65 10% of the chopper cycle it should be possible to obtain bursts with a duration of about $\frac{1}{30}$ nanoseconds. The deflection plates can be used with gas thyratrons or hard tubes. In the latter case higher repetition rates and rise times can be obtained.

In the deflector, assembly 14 of the deflection plate 52 is grounded and deflection plate 51 is held at a potential of approximately 10 kv. Similarly, the deflection plate 62 is grounded and deflection plate 61 is held at a positive potential of approximately 10 kv. The particle 75

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deflection in the region of the second pair of plates 61 and 62 due to the electric field between the plates is counterbalanced by the magnetic field supplied by the coils 67. The positively charged deflection plates 51 and 61 are connected to the thyratrons 55 and 65 which may be independently triggered to provide pulse length control. During the initial portion of the pulse, deflection plates 51 and 61 are positively charged such that the diverging beam pulse passing between the first pair of plates 51 and 61 is radially deflected from the axis of the deflection assembly, passes through the field of the focusing lens 46 where some image rotation is produced, and is focused in the slot 49 at the collector 47 radially displaced from the axially located collimating aperture 48. No deflection action is experienced by the converging beam in passing through the second pair of plates 61 and 62 because of the biased field condition.

When the first deflector plate 51 is rapidly discharged by triggering its driver thyratron 55, the beam suddenly becomes symmetrically located about the center line of the deflection system causing the focal point to sweep along slot 49 in the collector 47 into the collimating aperture 48 and provide injection into the prebuncher cavity 71 and subsequently into the accelerating structure. After a suitable controllable time delay, deflector 61 is discharged by its thyratron 65 and the DC magnetic bias field remaining in the region between the second pair of plates causes the beam to be deflected away from the collimating aperture 48 and swept onto the collector surface 47. One or more chopped and bunched particle bursts may be passed into the accelerating structure using this unique deflection assembly.

A number of advantages flow from this structure. The major advantage lies in the capability of continuous and smooth variations of pulse lengths from maximum cathode pulse lengths down to fractions of a nanosecond. Additionally, not only can very short pulses be produced but also they can be produced any time during the initial cathode pulse. For example, by selecting a portion at the middle of the pulse it is possible to avoid low current bursts such as occur during the rise and fall times of the pulse. This also permits selection of substantially constant energy particles for insertion into particle accelerators that can only accelerate particles over an extremely tight energy spread as required in sophisticated nuclear experiments.

The pulsing and accelerating structure in accordance with the present invention can produce either a high current or high energy particle pulse for performing a variety of experiments. In this regard with the three accelerating waveguides 17, 18 and 19 fed with power from the dual output klystron in the manner shown in FIG. 1, a high energy and medium current output can be achieved such as, for example, an output of 25 mev. and 270 ma. when each output arm of the klystron is carrying 8 mw. By switching the RF power remaining at the output end of the first accelerating section 17 from the phase shifter 22 to a load 92 indicated in phantom in FIG. 1 and directing the second output from the dual output klystron via line 91 as shown in phantom in FIG. 1 to the second accelerating section 18 instead of the third accelerating section 19, a high current medium energy particle output can be achieved at the output end of the second section 18. This high current output can be, for example, on the order of 1 amp at 11 mev. or 2.5 amps at 4 mev. or other values depending upon the operating parameters. This accelerator construction permits the trapping and bunching fields which vary from cavity to cavity in the initial accelerating waveguide 17 to be utilized and maintained for both the high current and high energy operations while the phase shifter 22 between the first and second accelerating sections 17 and 18 provides a means of varying the beam energy and counteracting the small phase shifts due to heavy beam loading.

In order to utilize the high current particle pulse from

the output of the second waveguide section 18, the third waveguide section 19 must be decoupled from the particle beam so that the net transfer of energy from the beam to the RF structure is zero. One possible arrangement to avoid beam losses in the third accelerating waveguide section 19 is to displace the third accelerating section 19 from the axis of the remaining accelerating structure 17 and 18. However this construction requires mechanical movement of accelerating guide 19 as well as the requisite opening of the high vacuum system.

As an aspect of the present invention provision is made for changing the operating temperature of the third accelerating waveguide 19 to phase slip the microwave circuit of that accelerating waveguide from the particle beam transmitted therethrough thereby permitting passage of the particle beam through accelerating waveguide 19 without energy loss due to induction of fields in the waveguide. Decoupling of this section is accomplished by adjusting the heater 20 to change the temperature of the cooling fluid and thereby the operating temperature of the waveguide. 20 In this manner the phase relationship between the particle bunches and the traveling wave continuously varies in such a manner that the net transfer of energy can be controlled to produce a zero net transfer of energy from the particle pulses of the RF structure.

By way of example, by changing the normal operating temperature of an S-band frequency waveguide as described in the example above from, for example, 40° C. to approximately 75° C. the waveguide can be decoupled from the high current, medium energy particle pulse emanating from section 18 so that this particle pulse can be directed through waveguide 19 without substantial loss of beam energy.

While the invention has been described with respect to a three section linear accelerator it can be utilized with 35 accelerators having a greater number of sections. Also the heater 20 is utilized to schematically illustrate a temperature control means. A cooling unit could be utilized.

While the invention has been described above with reference to positioning of the chopping cavity upstream of 40 the prebunching cavity this construction requires proper phasing between the signals as applied to the separate cavities and control of the induced fields in the prebuncher activity due to the chopped beam passing therethrough. Referring now to FIG. 6, there is shown a structure wherein 45 this beam-induced field is avoided. As shown, a pulse of charged particles is generated in the beam generating assembly 12 and passed through a chopping cavity 34 directly into the beam deflection and injection assembly 14 without clipping of the pulse on a collector. In the 50 deflection assembly 14 the successive pairs of plates 51–52 and 61-62 are utilized to sweep the pulse of particles across the collector 47 downstream thereof for passage of the portion of the pulse through the collimating aperture 48. In this arrangement the positions of the plates 55 61 and 62 are reversed so that instead of moving across the collimating aperture from one side of the other the pulse is moved into the aperture from one side an then moved back out of the aperture on the same side. The prebunching cavity 81 is positioned between the second pair 60 of plates 61 and 62 and the collector 47. This cavity 81 which is preferably a circular TM_{010} mode cavity is provided with an input disc wall 82 having an elongate slot 83 aligned with the deflection path of the charging particle pulse and an output disc wall 84 having a similarly 65 oriented slot 85.

In the operation of the device shown in FIG. 6 the chopper deflected pulse of particles introduced into the cavity 81 is swept across the collecter 47 by operation of the deflection plates in a manner similar to that de-70 scribed above with reference to FIGS. 1-5 to pass a portion of the pulse through the collimating aperture during each cycle of the chopper cavity. After passage of the particles through cavity 81 the pulse is bunched due to the influence of an RF signal coupled thereinto by a cou-75

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pling member 86. The end result is a beam path which positions the beam for passage through the collimating aperture 48 during a portion of the cathode pulse as shown in FIG. 8C. Only one collector is utilized and induced fields in the prebunching cavity due to only clipped portions of the beam passing therethrough are avoided.

Naturally many modifications can be made in the construction of the present invention without departing therefrom. For example, the counterbalancing magnetic field produced by the coils 67 can be omitted and both plates 61 and 62 maintained at the same positive potential until the end of the desired pulse length at which time one of the plates is discharged to ground. While the slot 49 in the collector 47 in the structure of FIGS. 1-5 is designed for sweeping the particle beam forwardly into the collimating aperture 48 and again forwardly out of the collimating aperture 48, it is obvious that the potentials on the deflecting plates can be selected for deflecting the particle beam forward into the collimating aperture 48 and then rearwardly out of the collimating aperture 48. Additionally, the chopping cavity can be placed downstream of the prebunching cavity; in this case velocity modualtion of the beam through the chopping cavity will result in an RF deflection pattern correspondingly modified, and this effect 25 may be used to enhance the selection of varied electrons for a tighter phase spread of resultant prebunched beams.

While the chopping cavity having a transverse magnetic field arranged across its center path has been described primarily for passage of only a portion of the particle beam therethrough, an arrangement of a pair of such cavities would also provide an extremely accurate beam position signal. For example, when located on the beam center line of a linear accelerator two rectangular TE_{102} cavities connected together and oriented at right angles can be adjusted to indicate in which quadrant the beam charge "center of gravity" lies. Similarly such a device with each cavity energized at the fundamental RF frequency but 90° out of electrical phase can deflect a beam passing therethrough to produce a circular scan at the RF cyclic frequency. Such a device can act as a bunch length monitor as a bunched beam of the same frequency made to pass through this device will produce only an arc of a circle such that the arc length divided by the full circumference and multplied by 360° gives the actual bunch length.

Since many changes can be made in the above construction and many apparently widely different embodiments of the invention can be made without departing from the scope thereof it is intended that all matter contained in the above description or shown in the accompanying drawings shall be interpreted as illustrative and not in a limiting sense.

What is claimed is:

1. An accelerating structure including a plurality of accelerating waveguides, means for directing radio frequency energy into each of said waveguides and for decoupling said radio frequency energy from one of said waveguides, means for directing charged particles through said waveguides for interaction with radio frequency energy therein for acceleration of said particles to relativistic velocities, means for cooling each said waveguides, and means for heating said one waveguide to change the dimensions of said one waveguide and electrically decouple said one waveguide from the particles passing therethrough.

2. An accelerating structure for providing high current medium energy charged particle beams and medium current high energy charged particle means comprising:

means for creating a beam of charged particles,

a plurality of accelerating waveguide sections including at least first, second and third accelerating sections for interacting with said beam,

input power means connected to said first section, a first phase shifting means connected between said input power means and said second and third sections

- for selectively directing power to said second section for high current medium energy beams and to said third section for medium current high energy beams,
- a second phase shifting means connected to said first and second sections,
- a load connected to said first section, and said first section including means for selectively directing power from said first section to said load for providing high current medium energy beams and to said second phase shifting means for providing medium high energy beams.
- 3. The accelerating structure of claim 2 including means for electrically decoupling at least one of said sections from the particle beam passing therethrough.
- 4. The accelerating structure of claim 3 wherein said 15 decoupling means includes means for selectively changing the temperature of said one of said sections.
- 5. The accelerating structure of claim 4 wherein said temperature changing means comprises a heater.
- 6. The method of changing the mode of operation of 20 an accelerator from a medium current high energy first mode to a high current medium energy second mode;
 - said accelerator comprising in said first mode means for creating a beam of charged particles; first, second and another accelerating waveguide sections for interacting with said beam; means coupling input power to the waveguide input of said first section and to the waveguide input of said other section; and coupling means between the waveguide output of said first section and the waveguide input of said second 30 section;

said method of changing to said second mode comprising the steps of:

decoupling the waveguide output of said first section from the waveguide input of said second 35 section;

decoupling said input power from the waveguide input of said other section and coupling said input power to the waveguide input of said second section;

and decoupling said other section from said beam.

7. The method of changing the mode of operation of

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an accelerator from a high current medium energy first mode to a medium current high energy second mode.

said accelerator comprising in said first mode means for creating a beam of charged particles, first and second accelerating waveguide sections for interacting with said beam, a phase shifter, input power means coupled to the waveguide input of said first section and to said phase shifter, and means coupling said phase shifter to the waveguide input of said second section,

said method of changing to said second mode comprising the steps of:

decoupling said phase shifter from said second section,

coupling the waveguide input of a third accelerating waveguide section to said phase shifter to interact with the beam from the second section, and coupling a second phase shifter between the waveguide output of said first section and the waveguide input of said second section.

8. In a charged particle beam device having means for passing a beam of charged particles through a waveguide section in a manner which will cause energy loss from the beam to the waveguide section at a given temperature of the waveguide section, the method of decoupling said waveguide section from said beam by changing the temperature of the waveguide section to change the dimension of the waveguide section and phase slip said waveguide from said beam to cause substantially zero net transfer of energy from the beam to the waveguide section.

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